

ADAPTER APPARATUS AND SEMICONDUCTOR PROCESS DEVICE

ABSTRACT

5 There are provided an adapter apparatus and a semiconductor process device
using the same. The adapter apparatus (300) is configured to connect a water resistance
meter (200) to a process tank (100), and includes a housing part (310) and a blocking
part (320), the housing part is provided with a first inner cavity (313), and the first
inner cavity is configured to be respectively connected with the process tank and the
10 water resistance meter; the blocking part is movably disposed in the first inner cavity
to be switched between a first position and a second position; in a case where the
blocking part is at the first position, the blocking part blocks the first inner cavity; and
in a case where the blocking part is at the second position, the process tank is connected
with the water resistance meter through the first inner cavity. The adapter apparatus
15 can avoid damage to the water resistance meter, and obviates the need for an operator
to detach and mount the water resistance meter, thereby overcoming the problems of
complex operation and low equipment productivity.

Fig. 1